



Appln. No.: 10/686,893  
Amendment Dated March 20, 2006  
Reply to Office Action of December 20, 2005

YAO-3990US3

Appln. No: 10/686,893  
Applicant: Hidetoshi Ishida, et al.  
Filed: October 16, 2003  
Title: ETCHANT AND METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE  
USING THE SAME  
TC/A.U.: 2823  
Examiner: Quovaunda Jefferson  
Confirmation No.: 8582  
Docket No.: YAO-3990US3

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**Expedited Procedure**

Mail Stop **AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated **December 20, 2005**, please amend the above identified application as follows:

☒ **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

☒ **Remarks/Arguments** begin on page 3 of this paper.

DO NOT ENTER  
3/22/2006